


<div>Search Notes</div> <div></div>	Application/Control No.	Applicant(s)/Patent under Reexamination	
	10/608,103	CHO ET AL.	
	Examiner	Art Unit	
	Jennifer M. Kennedy	2812	

SEARCHED			
Class	Subclass	Date	Examiner
438	3	11/12/2004	JMK
438	240	11/12/2004	JMK
update		5/13/2005	JMK
438	253-256	5/13/2005	JMK
438	396-399	5/13/2005	JMK

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
East text	11/12/2004	JMK
update (attached)	5/13/2005	JMK